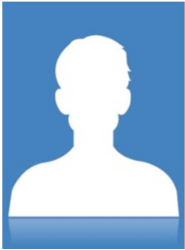


Advanced Nanotechnology and Device Fabrication for Range of Applications



Lead Guest Editor: Srismrita Basu

Affiliation: Process Engineer, Intel corporation, Hillsboro, Oregon, USA

Position:

Research Interests:

American Journal of Nanosciences (<http://www.ajnanosciences.org>) is really excited to announce the new special issue *Advanced Nanotechnology and Device Fabrication for Range of Applications* (<http://ajnanosciences.org/sinfo/359005>). This Special Issue represents an effort to capture current developments in Advanced Nanotechnology and Device Fabrication. Novel insights as well as fundamental research and analyses around the topics are welcomed. We are eagerly looking forward to seeing various Author's submissions along with their ingenious works.

Call for Paper

Potential authors are humbly requested to submit an electronic copy of their complete manuscript by <http://ajnanosciences.org/submission>

Submission Deadline	Dec. 25, 2019
Publication Deadline	Feb. 25, 2020

Topics of Interest include (but not limited to):

- ◆ Advanced nanomaterials
- ◆ Biomedical devices and applications
- ◆ Energy storage device
- ◆ Nano-bio-technology
- ◆ Lithography
- ◆ Solid state physics

Join as Guest Editor

For scholars who have intention to join the special issue as guest editor, please check out the link below: <http://ajnanosciences.org/jsqt/359005>

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